





U.S. Technical Advisory Group to ISO/TC 229 Nanotechnologies

TAG Working Group 2

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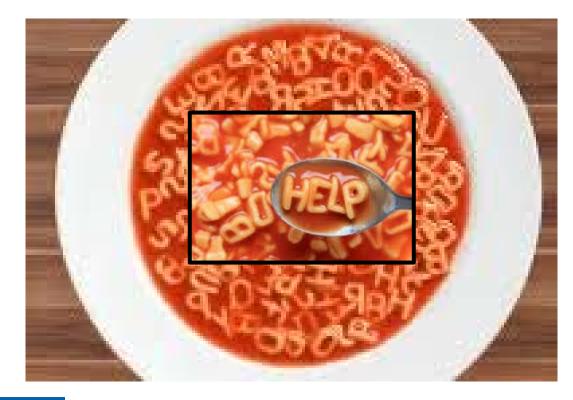
The Queen of Carbon





The Alphabet Soup of Standardization

TAG TC SC TWA41 TR TS IS BDS KCC



VAMAS ISO TC229 IEC TC113 OECD ASTM E56 IEEE











Documentary Standards Tool Box

Different tools for different market needs:

- National participation models
 - Treaty organizations; ISO, IEC
 - Formality in process
 - One country, one vote
- Direct participation models
 - ASTM International, SAE, IEEE, etc.
 - Direct link between technical experts and SDOs
- Corporate participation models
 - Consortia and fora
 - Wide range of processes and procedures allows flexibility





ISO/TC 229 Nanotechnology



Secretariat: UK Convener: UK

Participating countries: (P) **37** Observer Countries: (O) 13

170

Total number of published ISO 52 standards

Attendees at Plenary Scope:

Standardization in the field of nanotechnologies that includes either or both of the following:

- Understanding and control of matter and processes at the nanoscale, typically, but not exclusively, below 100 nanometres in one or more dimensions where the onset of size-dependent phenomena usually enables novel applications,
- Utilizing the properties of nanoscale materials that differ from the properties of individual atoms, molecules, and bulk matter, to create improved materials, devices, and systems that exploit these new properties.

Specific tasks include developing standards for: terminology and nomenclature; metrology and instrumentation, including specifications for reference materials; test methodologies; modelling and simulations; and science-based health, safety, and environmental practices.



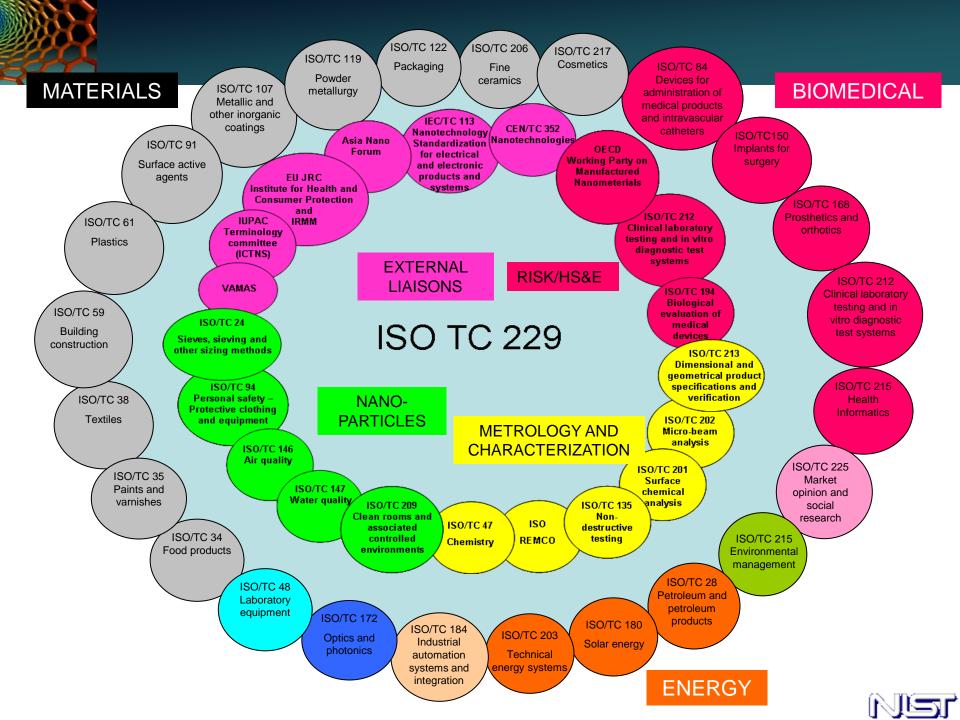
ISO Documentary Standard Types

- PAS Publicly Available Specification
- TR Technical Report
- TS Technical Specification
- IS International Standard

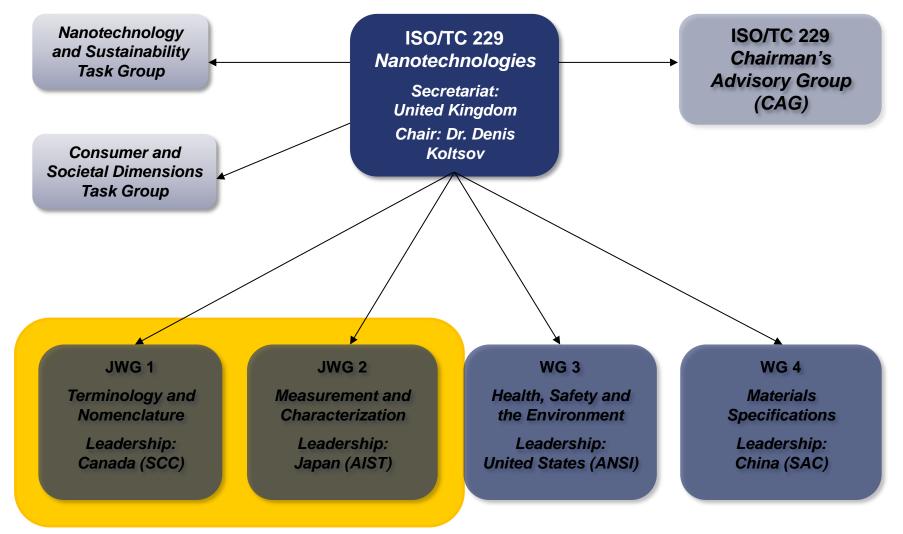


- PWI Preliminary Work Item
 - Vote
- WI Work Item
 - Vote
- Publish





ISO/TC 229 ORGANIZATION



WG= Working Group

JWG 1 Terminology and Nomenclature



ISO/TC 229/SC N 1410 Date: 2016-07-22 ISO/DTS 80004-13 ISO/TC 229/SC /JWG 1 Secretariat: BSI

Technical Specification

Terms related to methods to produce graphene and related 2D materials

3.2.1

graphene

graphene layer

single-layer graphene

monolayer graphene

single layer of carbon atoms with each atom bound to three neighbours in a honeycomb structure

Note 1 to entry: It is an important building block of many carbon nano-objects.

Note 2 to entry: As graphene is a single layer, it is also sometimes called monolayer graphene or single-layer graphene and abbreviated as 1LG to distinguish it from bilayer graphene (2LG) and few-layered graphene (FLG).

Note 3 to entry: Graphene has edges and can have defects and grain boundaries where the bonding is disrupted.

[SOURCE: ISO/TS 80004-3:2010, 2.11, modified - Notes 2 and 3 added]





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- 6 Matrix of properties and measurement techniques for graphene and related 2D materials

Table 1 — Matrix of properties and measurement techniques for graphene and related 2D materials

ISO/7	Table 1 — Matrix of properties and measurement techniques for graphene and related 2D materials																				
Tech techr	Techniques Properties		AFM	BET	EDS	EPMA	ESR (EPR)	Hall Bar	ICP-MS	LEEM	Optical Microscopy	Raman	SEM	SKPM	STM	TEM	TGA	SdD	UV-VIS-NIR Spectroscopy	XPS	Electrical Probing (4-point Probe)
mate		Number of Layers										0		0		0			0		
• Le	Vertical Dimension	Thickness	0							0						0					
	Dimension	Stacking Angle													0	0					
	Lateral Dimension	Flake Size	0								0		0			0					
		Domain (grain) Size									0	0			\bigcirc	0			\circ		
		Surface Area		0																	
		Crystal Defect	0		0	0	0					0	0		0	0					

ISO/PWI 21356

Preliminary Work Item - Structural Characterisation of Graphene

CVD-grown Graphene													0				
And Graphene Powders																	
										0							
N€	Need to validate methods through VAMAS													0			
		Electrical Conductivity															0
_	Electrical Property	Mobility						0									
		Work Function	0									0		0		\circ	



Technical Working Area (TWA) 41





Home > Technical Working Areas >

VAMAS home

Representatives

Connections

Contact us

Members Area

Structure

Formation & Objectives

Technical Working Areas

TWA 41

Led by UK and China Plan to start early summer Protocol based on NPL Good Practice Guide Companies CAN participate!

Graphene and Related 2D Materials

Due to its many exceptional properties, graphene is predicted to impact many different industry application areas such as solar cells, biosensors, displays, composites, flexible electronics and energy storage. As industry uptake on this material increases, standardization will be increasingly required to enable commercialization. Particularly important for its uptake is the reliable, accurate and reproducible measure of the different properties of the material. This is because there are issues with both differing routes of production and batch-to-batch consistency.



The objective of this TWA will be to validate different methodologies of measurement for graphene and related 2D materials. Determining the uncertainties associated in measurement, sample preparation, and data analysis. Interlaboratory studies will be conducted and the results will form the basis for future standardisation.

Project Areas

Structural characterisation of CVD grown graphene:

Coverage on substrate, number of layers, level of disorder

Chemical composition of graphene flakes:

- 2. Elemental analysis and oxygen content
- 3. Measurement of the Metal impurities



10 Questions from the Metrology Check-List

Question 1: Has the system / body / substance that will be subjected to the measurement procedure, clearly been described, including its state?

Question 2: Is the definition of the system / body / substance not unnecessarily restrictive?

Question 3: Is the measurand clearly described?

Question 4: Has it been clearly indicated whether the measurand is operationally defined (or method-defined), or whether the measurand is an intrinsic, structurally defined property?

Question 5: Is the measurement unit defined? Are the tools required to obtain metrological traceability available? Question 6: Has the method already been validated in one or more laboratories?

Question 7: Are any quality control tools available to enable the demonstration of a laboratory's proficiency with the test method?

Question 8: Have the results of measurements using the proposed method already been published in peer-reviewed journals by several laboratories?

Question 9: Is the instrumentation required to perform the test widely available?

Question 10: Does the document propose a measurement uncertainty budget?



How to know when

....the measurement science is ready to be standardized?

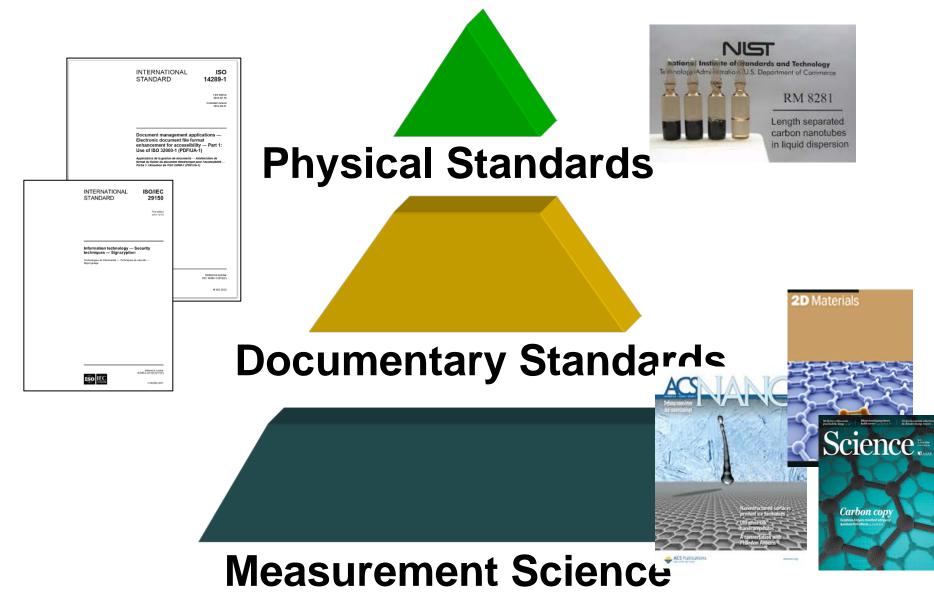
And more importantly

•standards are really needed?

Standards are for industry



The Metrological Approach at NIST



National Institute of Standards and Technology







